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PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/797,046 Group Art Unit: 2811
Filing Date: March 11, 2004 Examiner: Ori Nadav
Applicant: Jung-Hyun LEE et al.
Title: METHOD FOR MANUFACTURING OXIDE FILM HAVING HIGH
DIELECTRIC CONSTANT, CAPACITOR HAVING DIELECTRIC FILM
FORMED USING THE METHOD, AND METHOD FOR
MANUFACTURING THE SAME
Attorney Docket: 2557SI-001239/US

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Alexandria, VA 22314
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April 16, 2010

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the Final Office Action mailed February 16, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims begin on page 2 of this Amendment.

Remarks begin on page 3 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	2	-	20	=	0
Independent	1	-	3	=	0